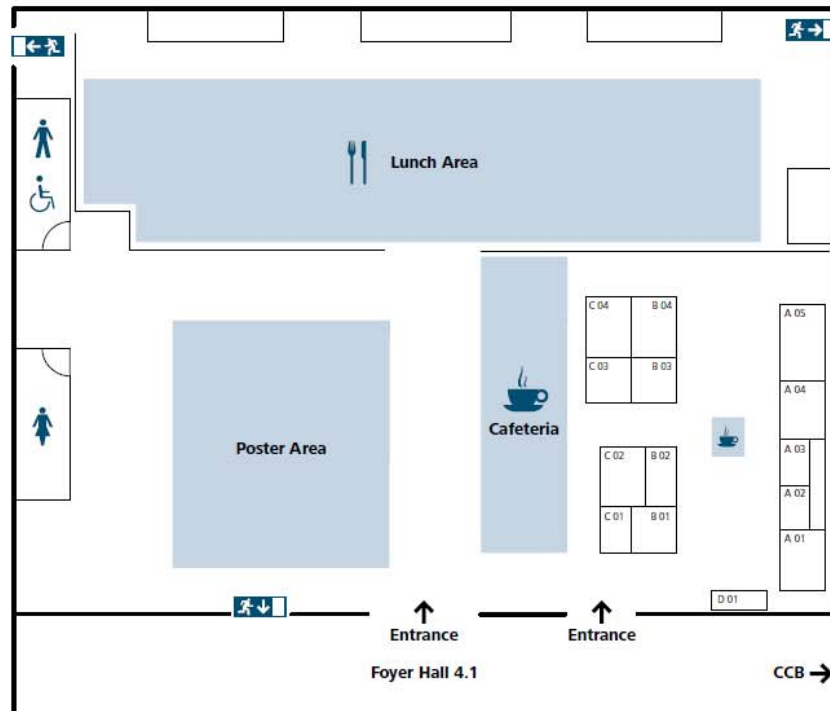


# ACTUATOR 18

## Hall 4.1



Preliminary Floorplan  
Issue: 30.05.2018 16:49h

| Exhibitor   | Stand             |
|---|-------------------|
| <b>B</b><br>Boréas Technologies Inc.  | A02               |
| <b>C</b><br>CEDRAT TECHNOLOGIES S.A.<br>CeramTec GmbH<br>CTS Corporation                      | C01<br>C02<br>B03 |
| <b>E</b><br>Elektronik / WEKA FACHMEDIEN GmbH<br>ETO MAGNETIC GmbH                            | D01<br>B04        |
| <b>F</b><br>FGL-Netzwerk<br>Fraunhofer-Allianz Adaptronik                                     | A01<br>B01        |
| <b>H</b><br>hivolt.de GmbH & Co. KG   | B02               |
| <b>J</b><br>Johnson Matthey Piezo Products GmbH   | A05               |
| <b>M</b><br>Microfine Materials Technologies Pte Ltd<br>Mikroproduktion / MIKROvent GmbH      | A03<br>D01        |
| <b>P</b><br>Physik Instrumente (PI) GmbH & Co. KG<br>PI Ceramic GmbH<br>piezosystem jena GmbH | C03<br>C03<br>A04 |
| <b>R</b><br>G.RAU GmbH & Co. KG   | C04               |
| <b>S</b><br>SENSOR MAGAZIN/LASER MAGAZIN<br>c/o Magazin Verlag<br>Hightech Publications KG    | D01               |